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Application Number		10677849
Filing Date		2003-10-02
First Named Inventor	Yoshi	iyuki Abe
Art Unit		1796
Examiner Name	Mark	T. Kopec
Attorney Docket Number		KAM 20.660

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	2	2004043851	JP			2004-02-12	SUMITOMO META MINING CO	ı.			Г	
	3	1174390	EΡ			2002-01-23	JAPAN SCIENCE TECHNOLOGY CORPORATION	AND				

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	4	0793277	EP		1997-09-03	CANON KABUSHIKI KAISHA				
	5	0686982	EP		1995-12-13	HOYA CORPORATION				
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	1	R. GROTH, "Investigation of semiconductor indium oxide Films", 1996, pg(s) 69-75, Phsyca Status Solidi, Philips Zentrallaboratorium GmbH, Aachen, Germany(without translation)								
	2	A.E. DELAHOV, et al., "Transparent and semitransparent concluding film deposition by reactive-environment, hollow cultrod sputtering". Journal of Vacuum Science and Technology A. Vacuum, Surfaces and Films, June 28, 2005, pg(s) 1215-1220, Vol. 23, no. 4, American Institute of Physics, New York, NY U.S.								
	3	SAFI, et al., "The properties of reactively-sputtered, stoichiometry-controlled and optimum-conductivity transparent inclum coxide films as a function of their titisatum, altuminum and zinc content, comparisons with the use of fin as a doppan," April 1999, vol. 343-344, pg(s) 115-118, Dept. of Physics, Loughborough University, Loughborough, UK.								
	4	G. CAMPET, et al., "The electronic effect of T14+, ZR4+ and GE4+ dopings upon the physical properties of IN203 and SN doped IN203 ceramics: application to new highly-transparent conductive electrodes", June 20, 1993, pg(s) 285-289, vol. B19, no. 3, Lausanne, CH								
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	8	Summons to attend onel proceedings pursuant to Rule 115(1) EPC dated December 28, 2007 for corresponding European Application EP 03 256 274					
	9	European Search Report and Annex to the European Search Report dated March 8, 2006, for corresponding European Application EP 03 256 274					
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